

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10550924
	Filing Date		2006-10-10
	First Named Inventor	Mitsuru Furusawa	
	Art Unit	1633	
	Examiner Name	Michael D. Burkhart	
	Attorney Docket Number	38573/4	

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	1	2004225648	AU	B2	2004-10-14	Neo-Morgan Laboratory	Notice of Acceptance	<input type="checkbox"/>

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1	LI et al., "Sensitivity to Phosphonoacetic Acid: A New Phenotype to Probe DNA Polymerase-delta in Saccharomyces cerevisiae," Genetics, Vol. 170:569-580, June 2005.	<input type="checkbox"/>
2	MCELHINNY et al., "Inefficient Proofreading and Biased Error Rates During Inaccurate DNA Synthesis By a Mutant Derivative of Saccharomyces cerevisiae DNA Polymerase-delta," J. Biol. Chem., Vol. 282:2324-2332, Jan 2007.	<input type="checkbox"/>
3	VENKATESAN et al., "Mutator Phenotypes Caused by Substitution at a Conserved Motif A Residue in Eukaryotic DNA Polymerase-delta," J. Biol. Chem., Vol. 281:4486-4494, Feb 2006.	<input type="checkbox"/>

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